

# Making light work in microscopy

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University of Oxford

## Optically sectioning microscopes

through-focus series of images  
three-dimensional imaging

## Light efficient implementation

aperture correlation  
structured illumination

## Fast focussing

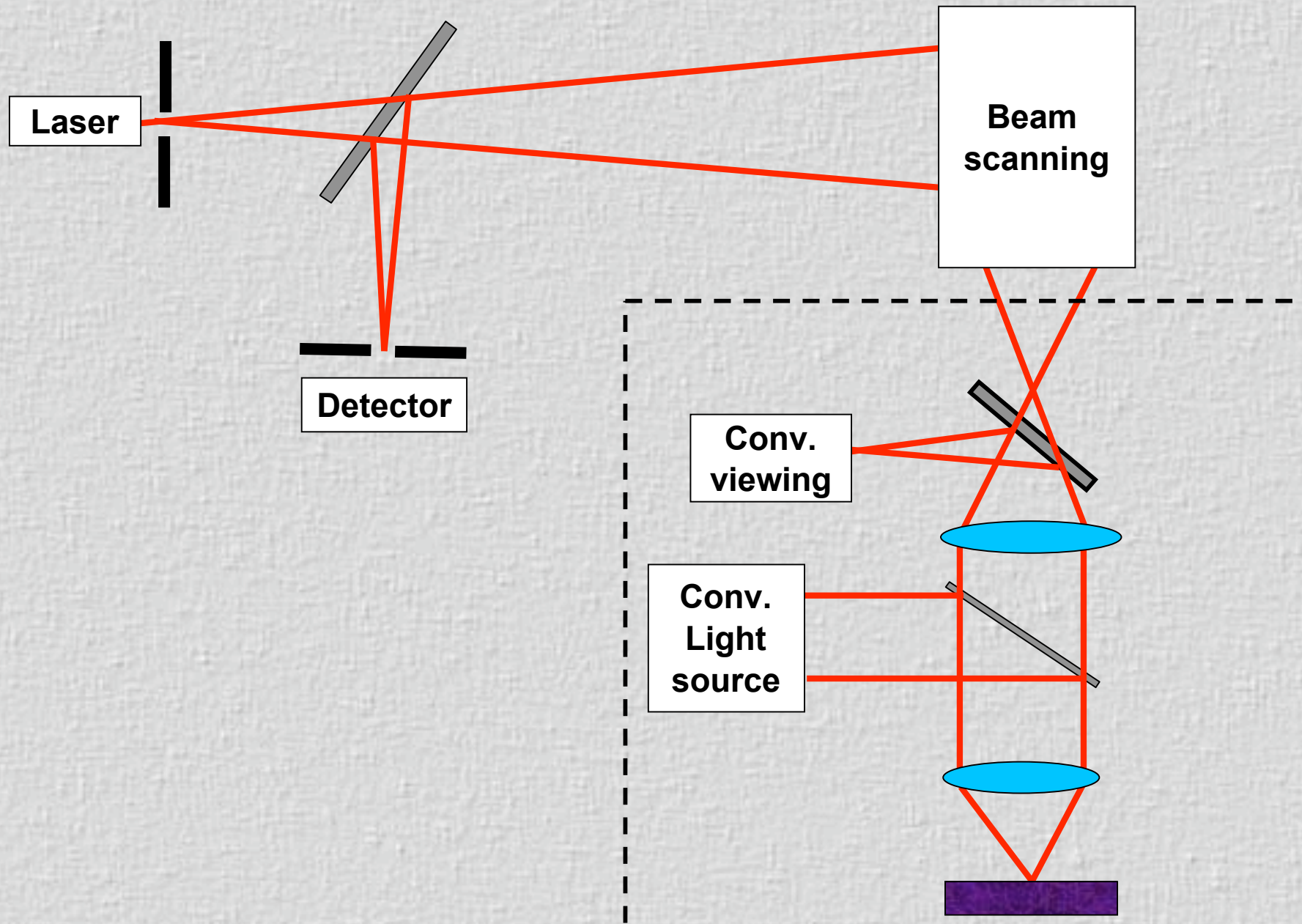
live cell imaging

**Structured  
illumination**

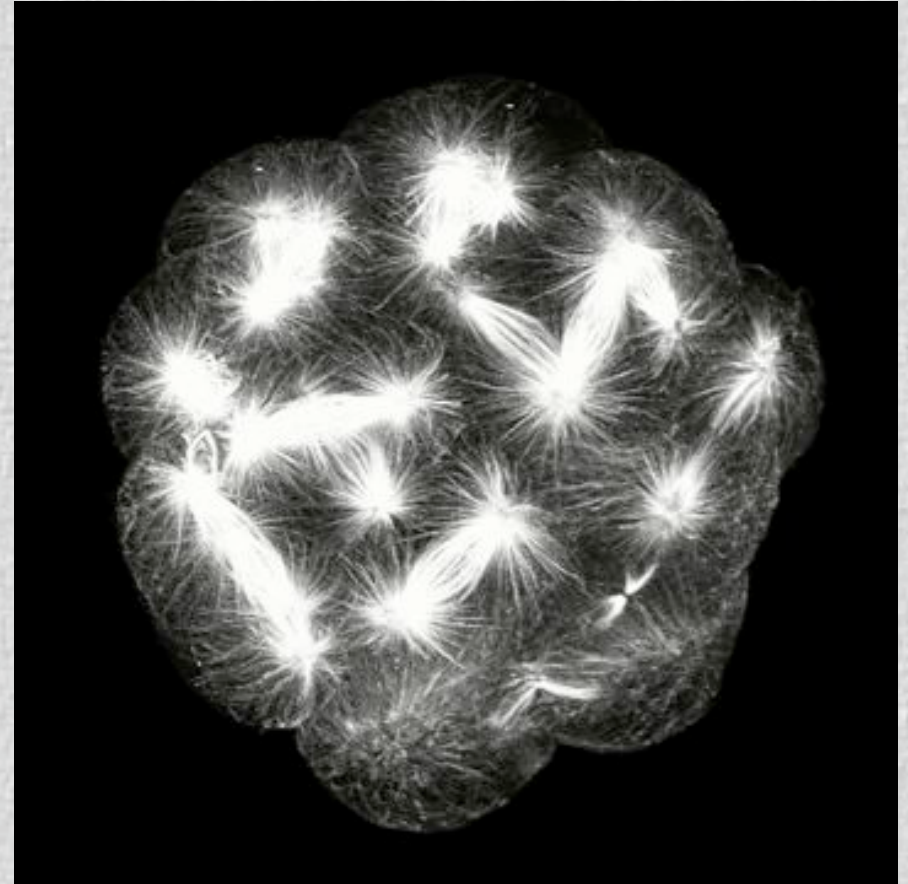
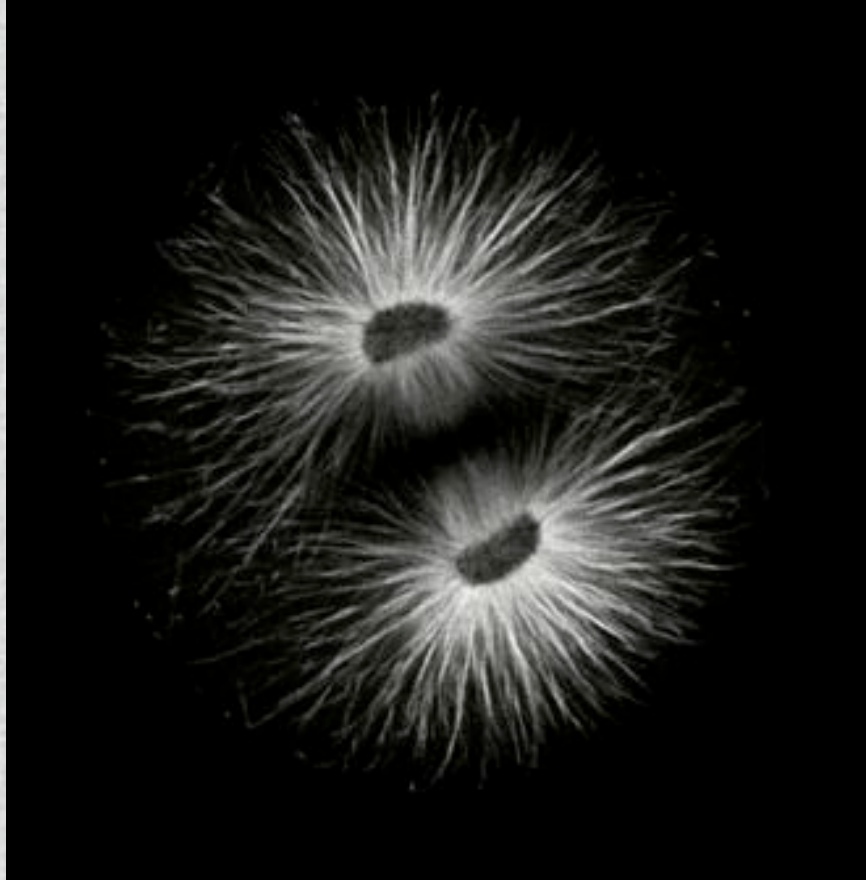




# Confocal Microscope



# Embryo





# Drawbacks

- **Lasers**
  - ∨ **Brightness**
  - ∨ **Limited wavelength choice**
- **Usually not real time**
- **Pinhole alignment problems**
- **Need to scan**

# Goals

- **Lasers**

- ∨ **Brightness**

- ∨ **Limited wavelength choice**

**No laser**

- **Usually not real time**

**Real time**

- **Pinhole alignment problems**

**Easy alignment**

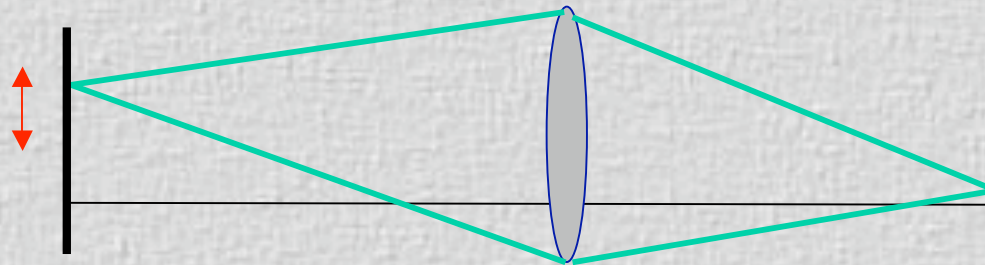
- **Need to scan**

**No scanning**

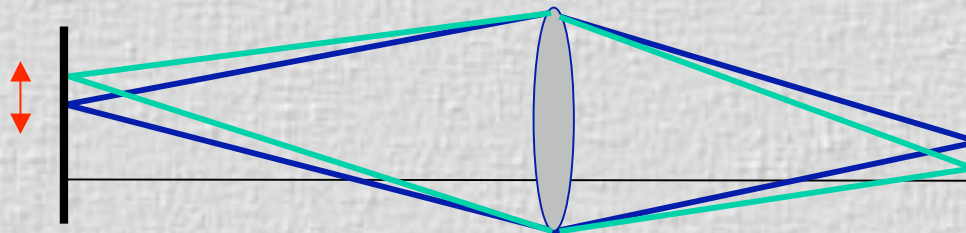


# The principle

- Single point system



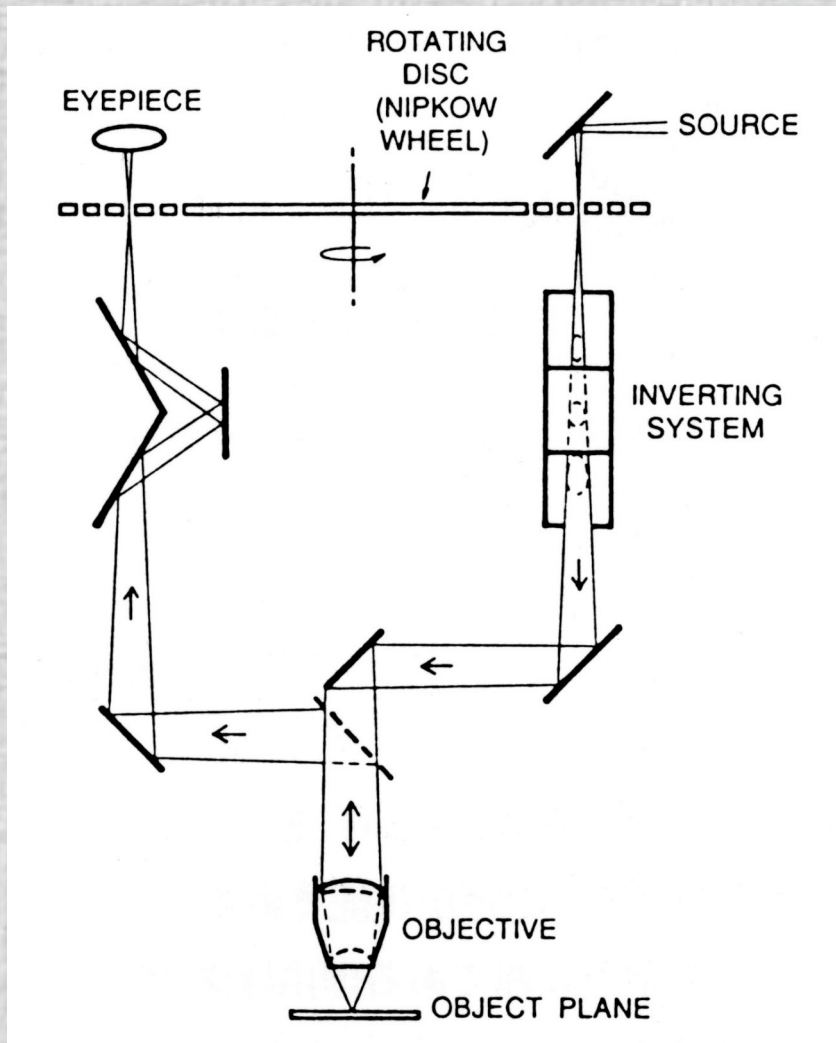
- Two point systems



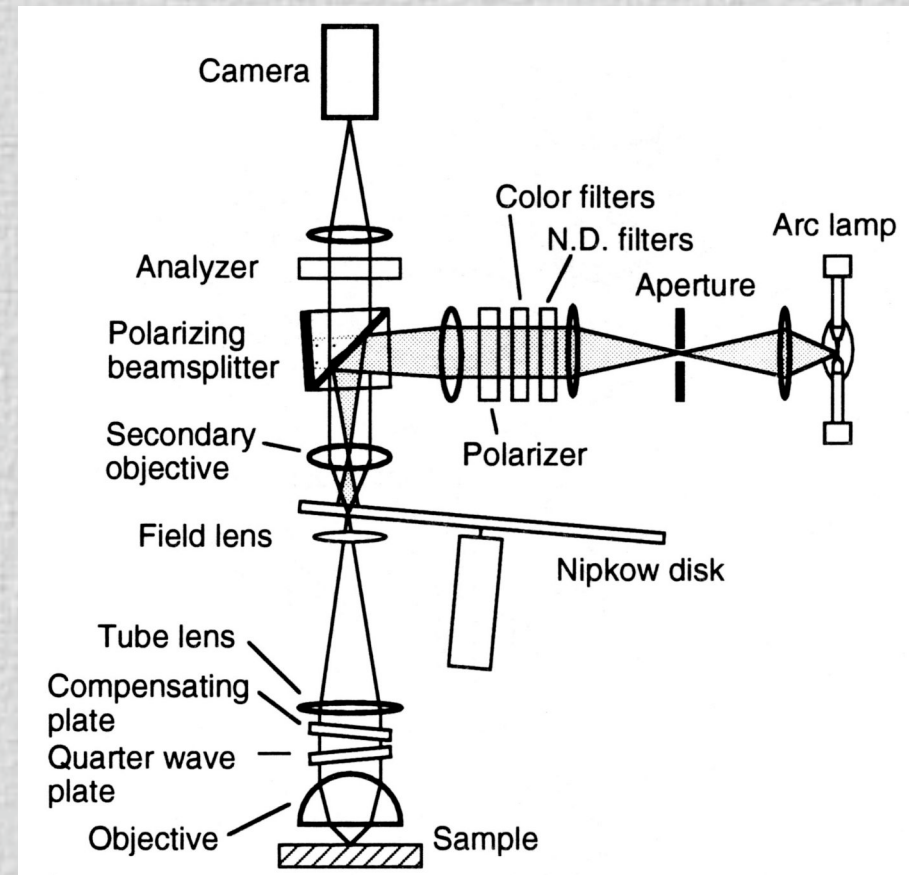
Multiple point --- TSM

space pinhole far apart --- cross talk

# TSM schemes



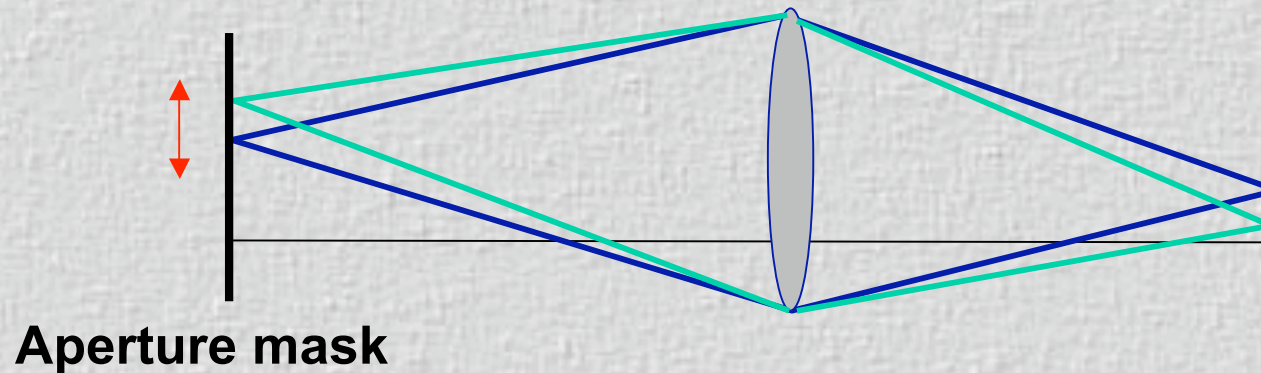
Original Petran scheme



Kino approach



# Aperture correlation



**Place pixels close together**

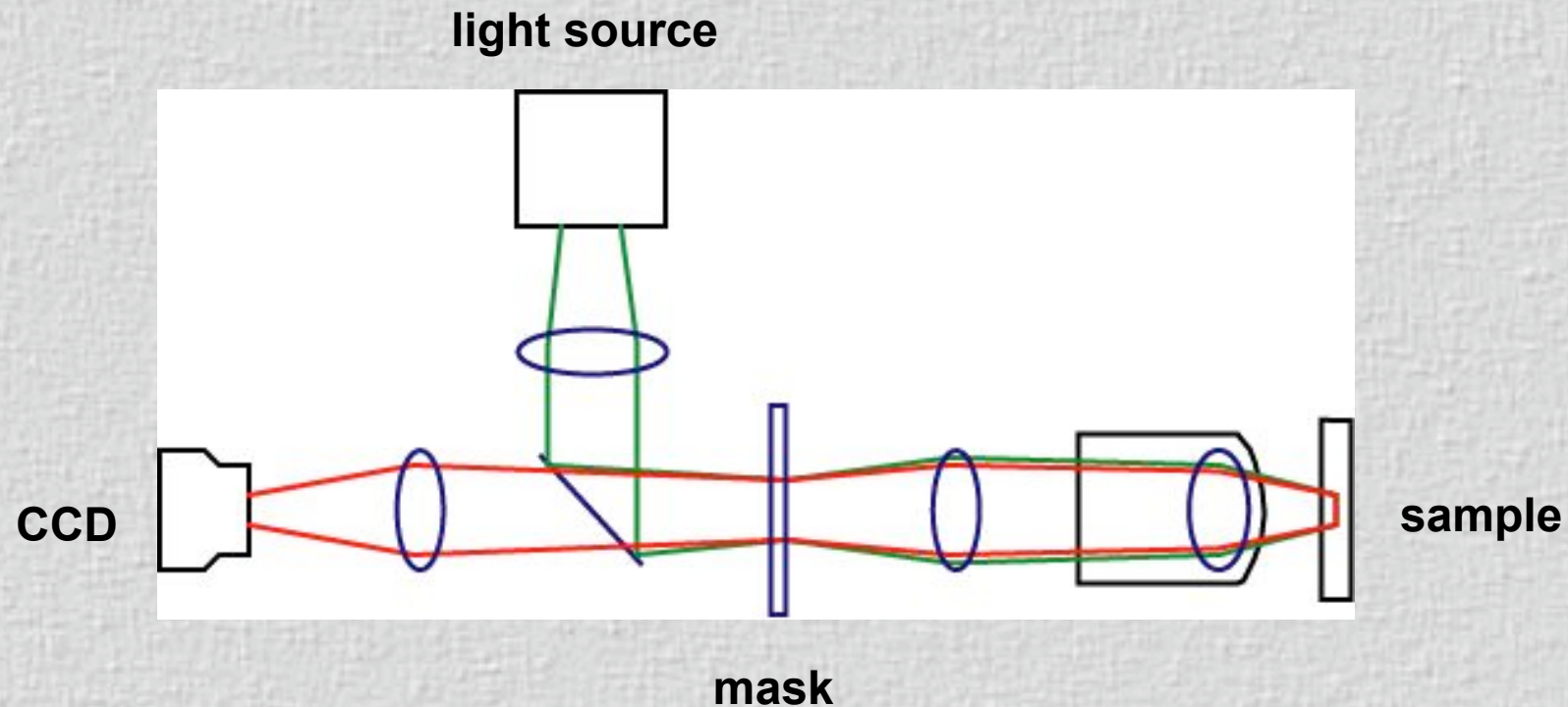
**Use time sequential pixel transmission,  $b_i(t)$**

$$\langle b_i(t) b_j(t) \rangle = \delta_{ij} \qquad \langle b_i(t) \rangle = 0$$

**No cross-talk**

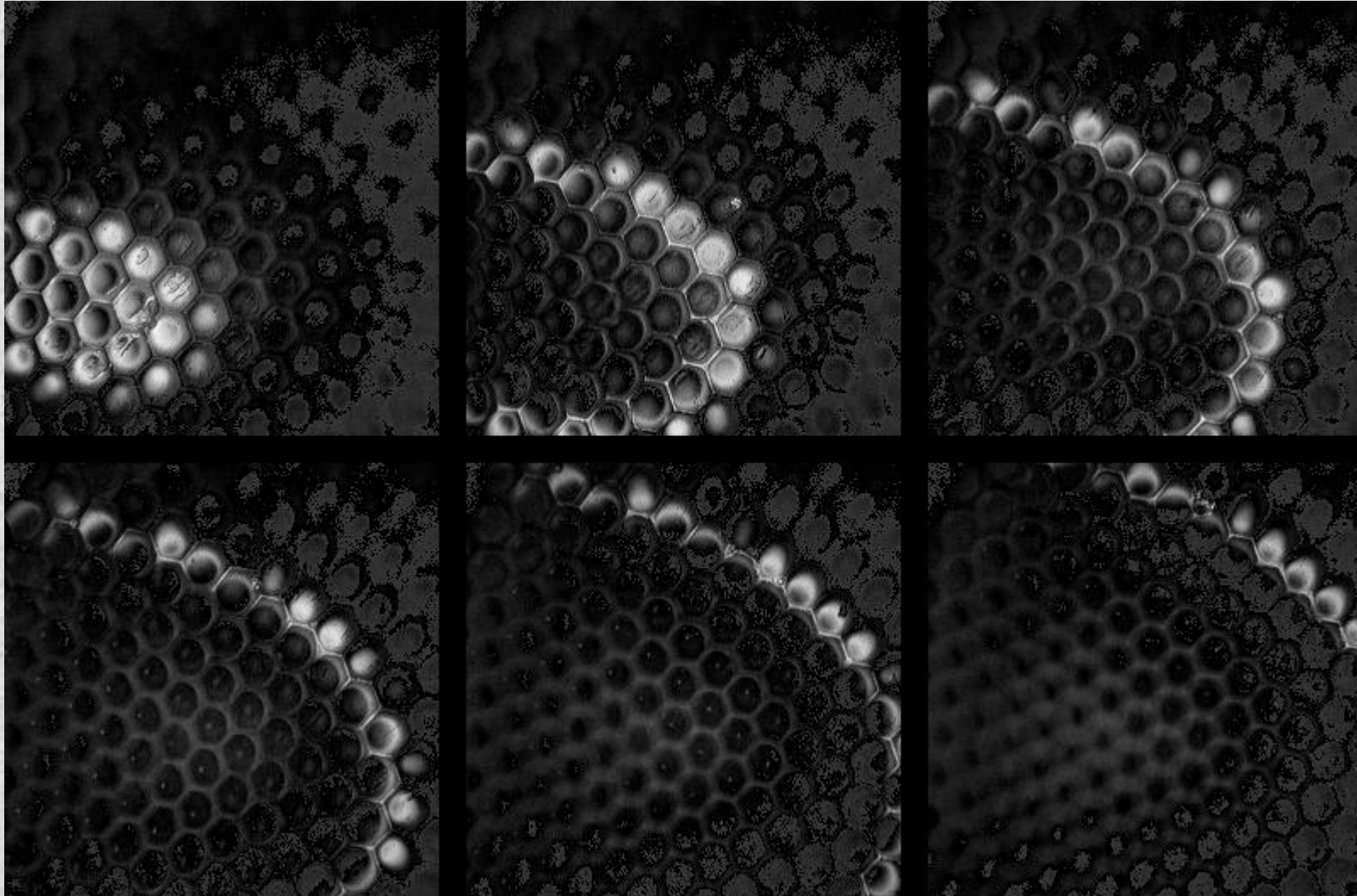


# The system



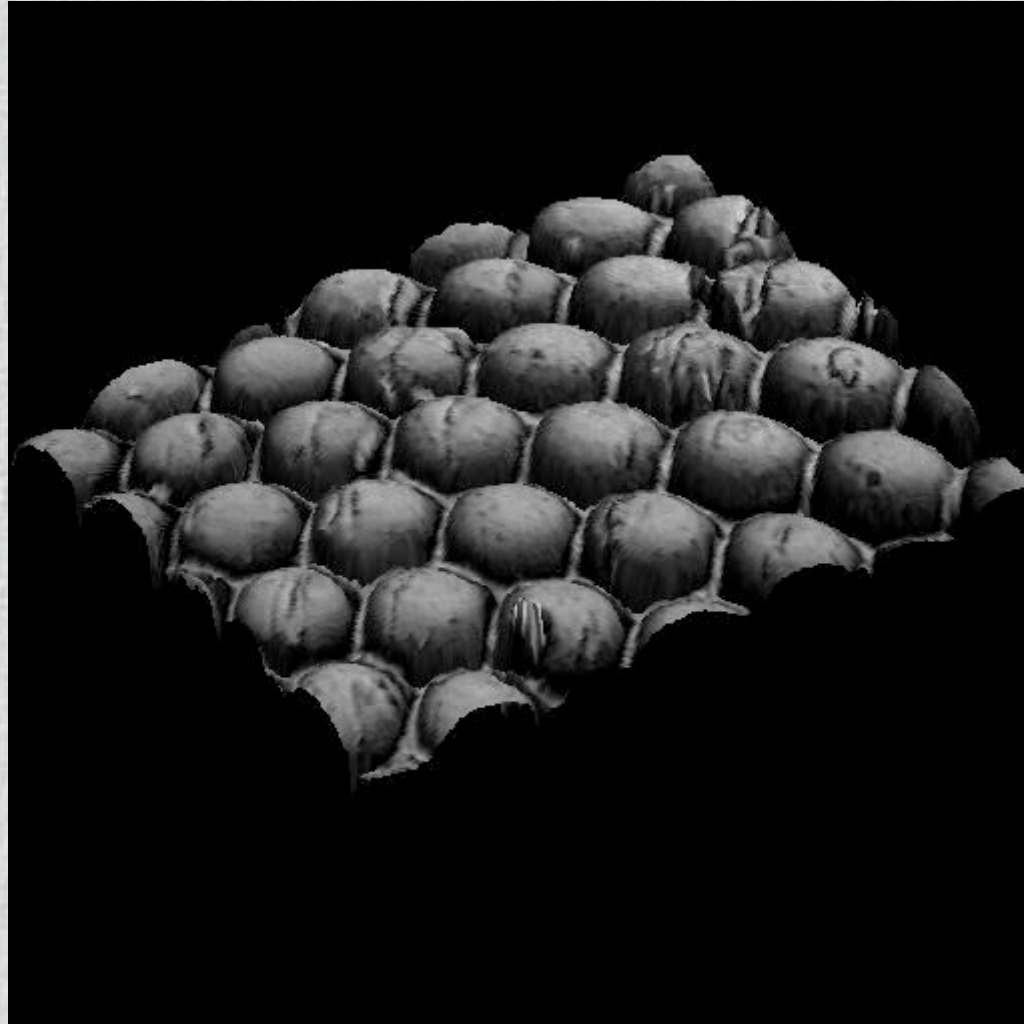
- mask encodes pattern and performs reciprocal filtering
- averaging required to remove pattern
- standard microscope illuminator
- 25 (30) confocal frames/second

## Through focus series – fly's eye





# Fly's eye

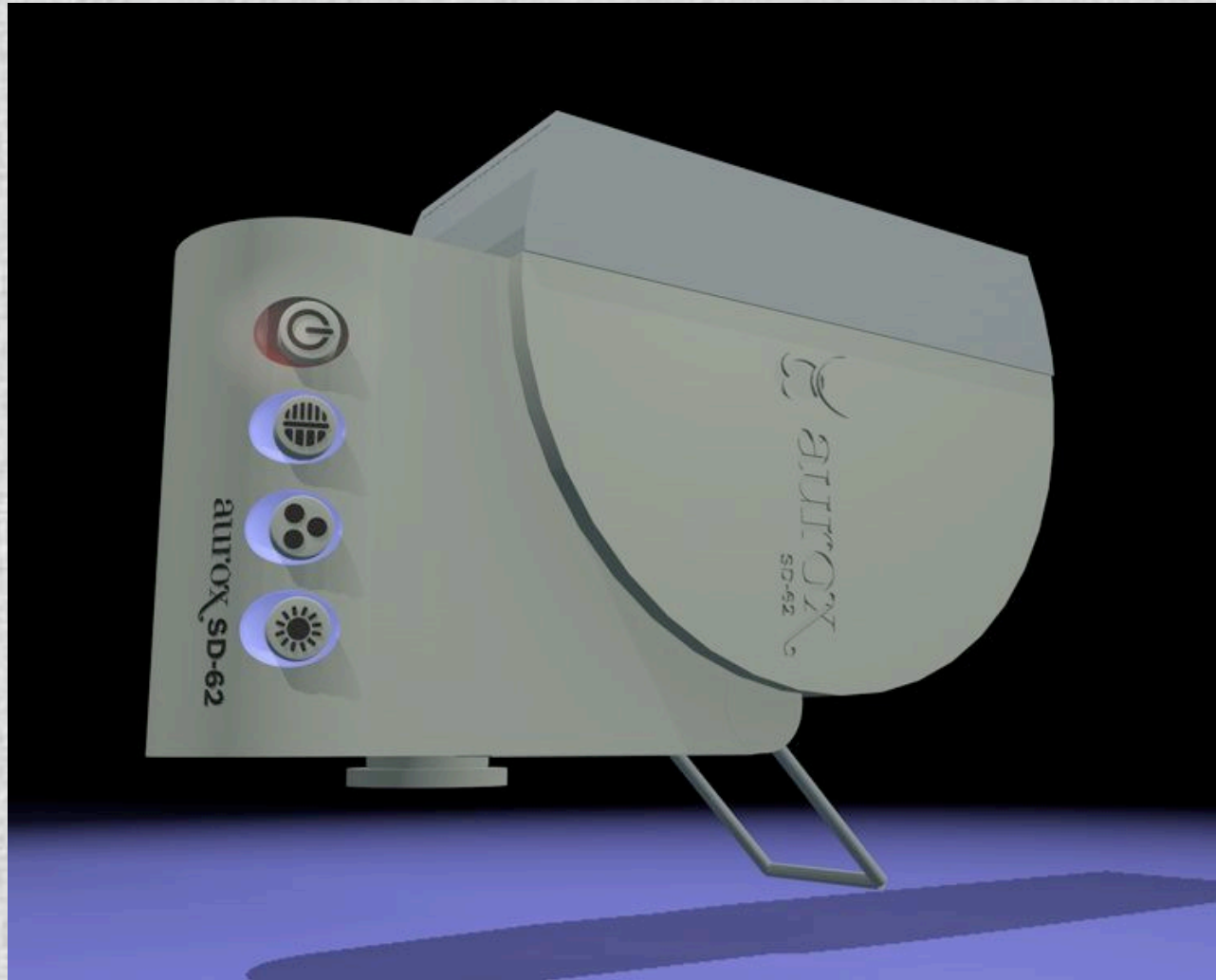


# Transistor





# Aurox SD-62



# Aurox SD-62





# Goals

- **Lasers**
  - ∨ **Brightness**
  - ∨ **Limited wavelength choice**

**No laser**

- **Usually not real time**

**Real time**

- **Pinhole alignment problems**

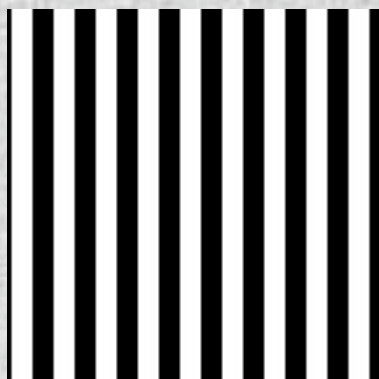
**Easy alignment**

- **Need to scan**

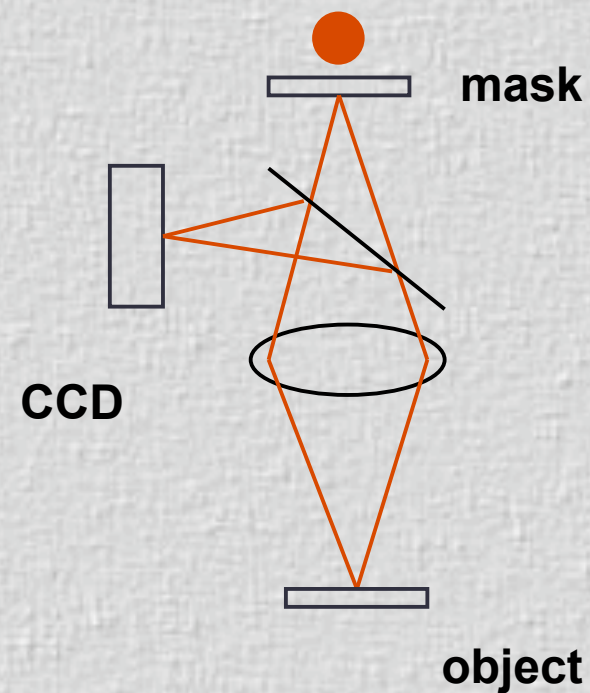
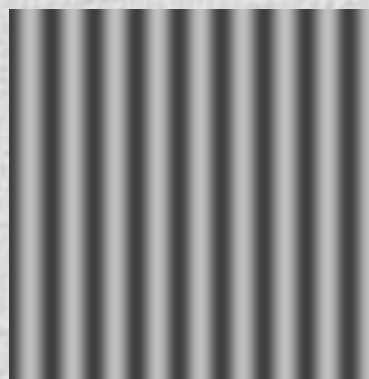
**No scanning**

# Example: grid illumination

illumination mask



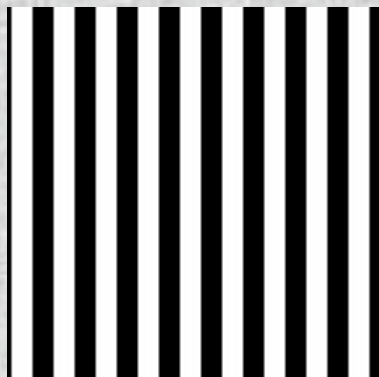
image



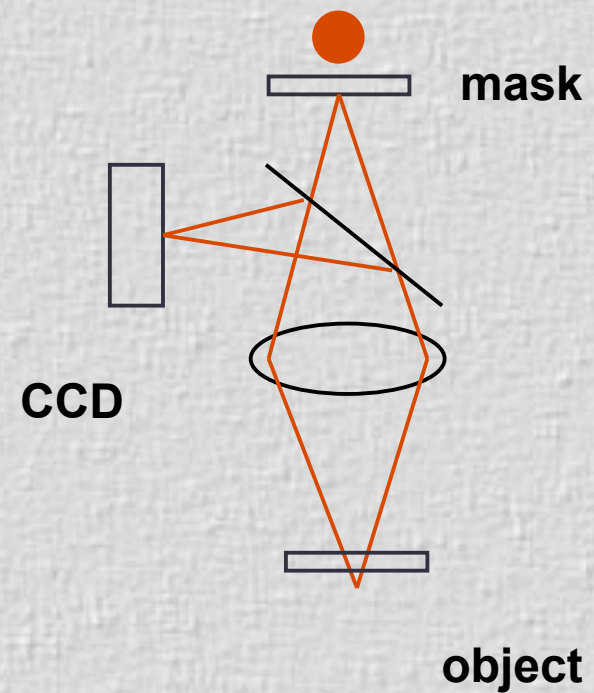


# Example: grid illumination

illumination mask

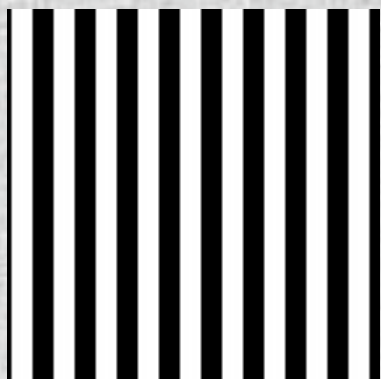


image

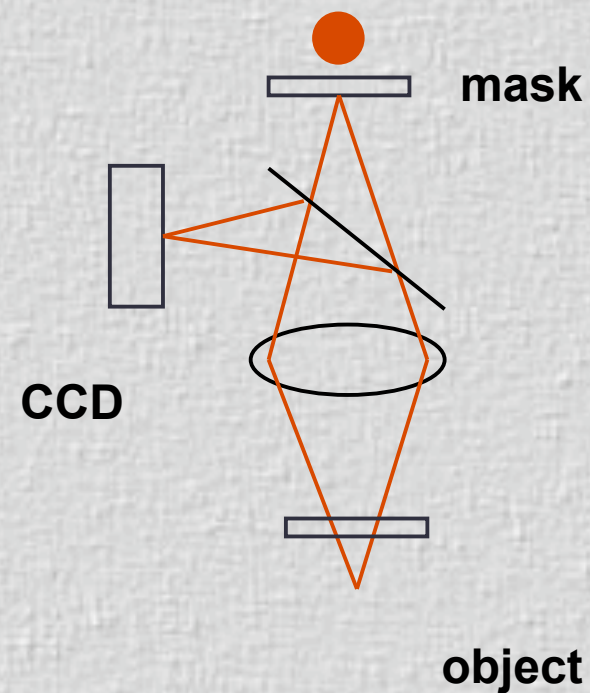
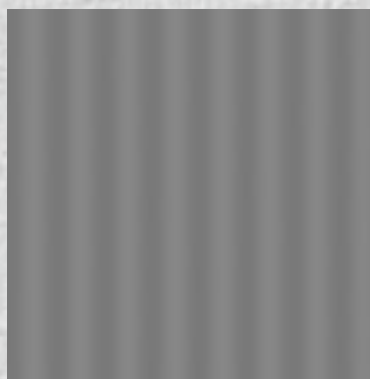


# Example: grid illumination

illumination mask



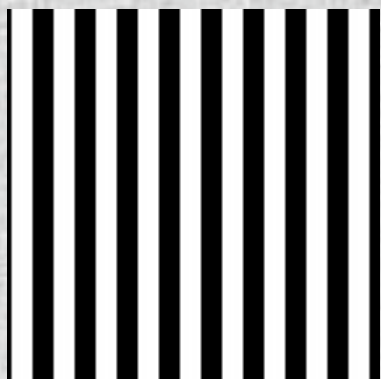
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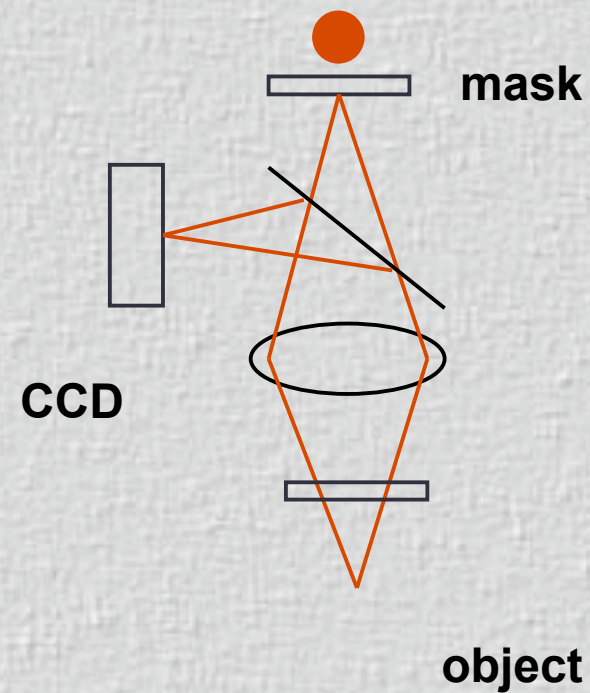


# Example: grid illumination

illumination mask

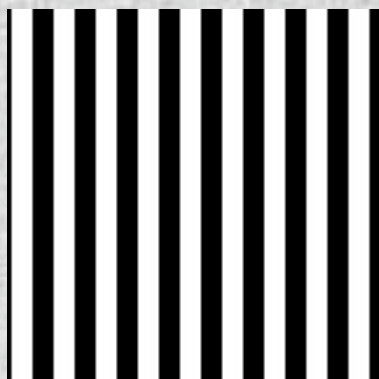


image

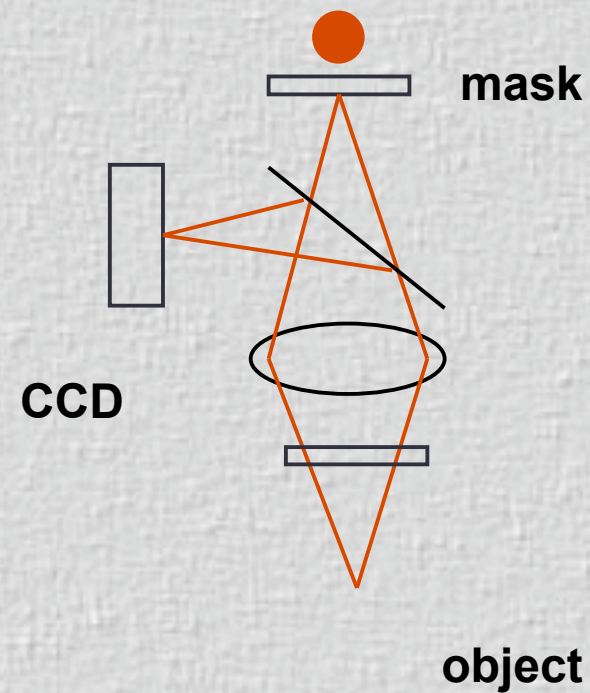


# Example: grid illumination

illumination mask

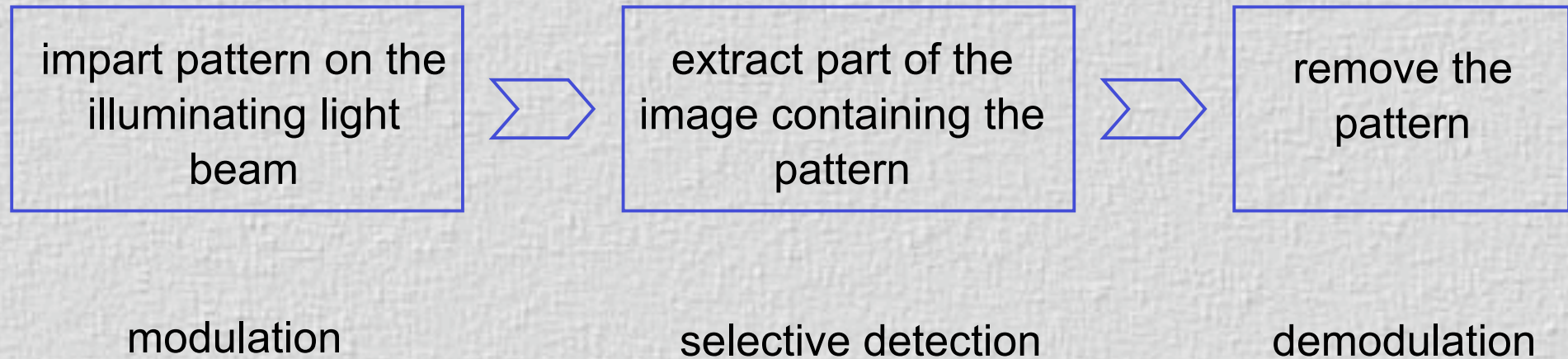


image





# Structured illumination microscopy

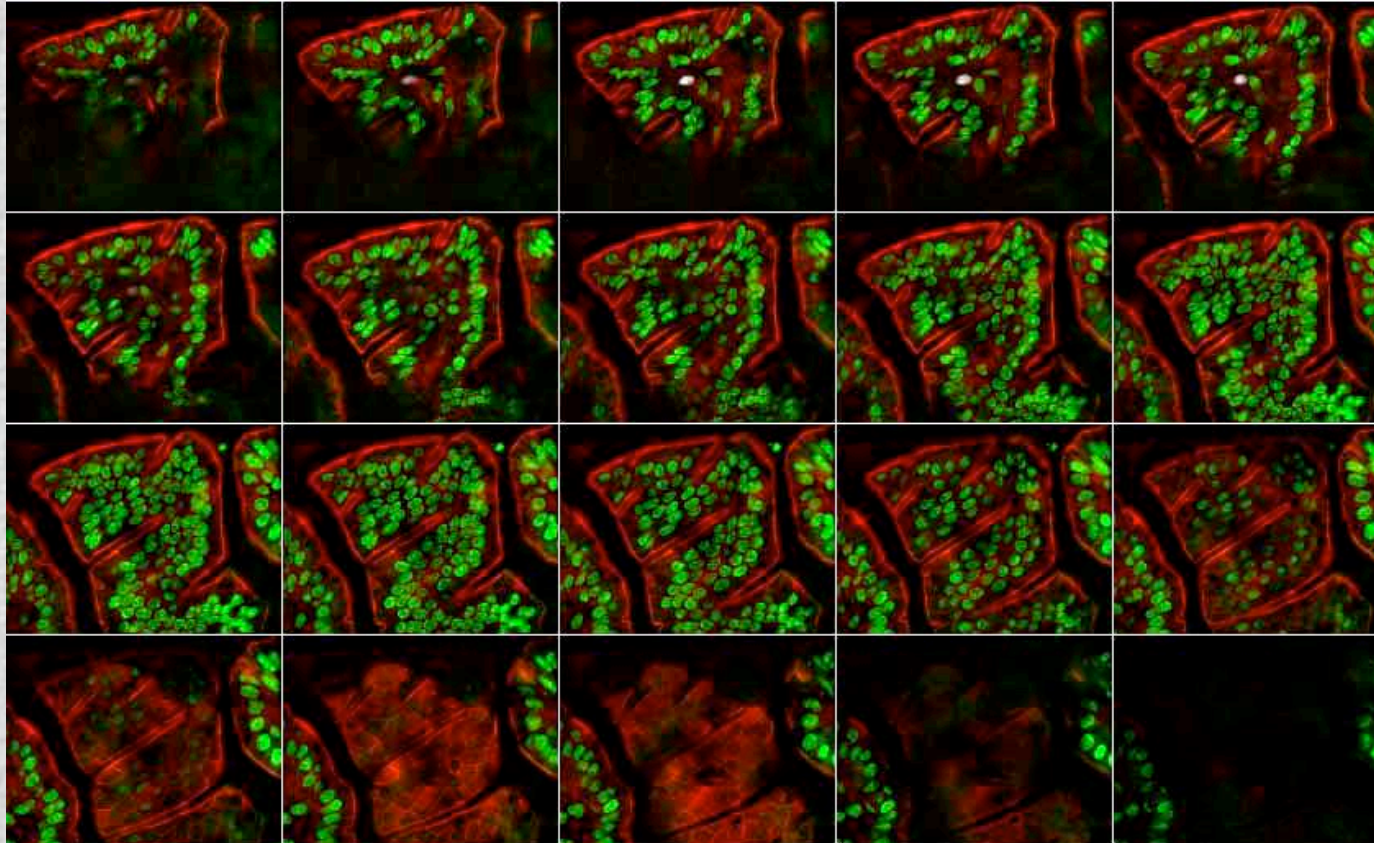


**Add-on to  
conventional microscope**

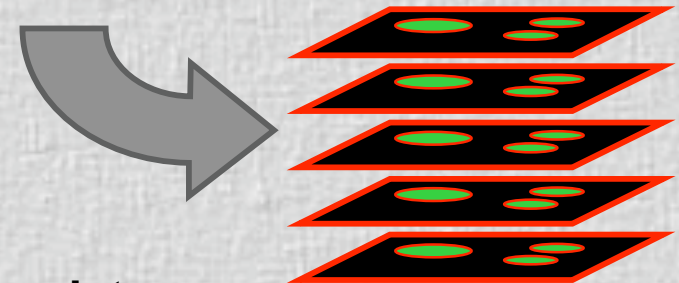




# Sectioning microscopy



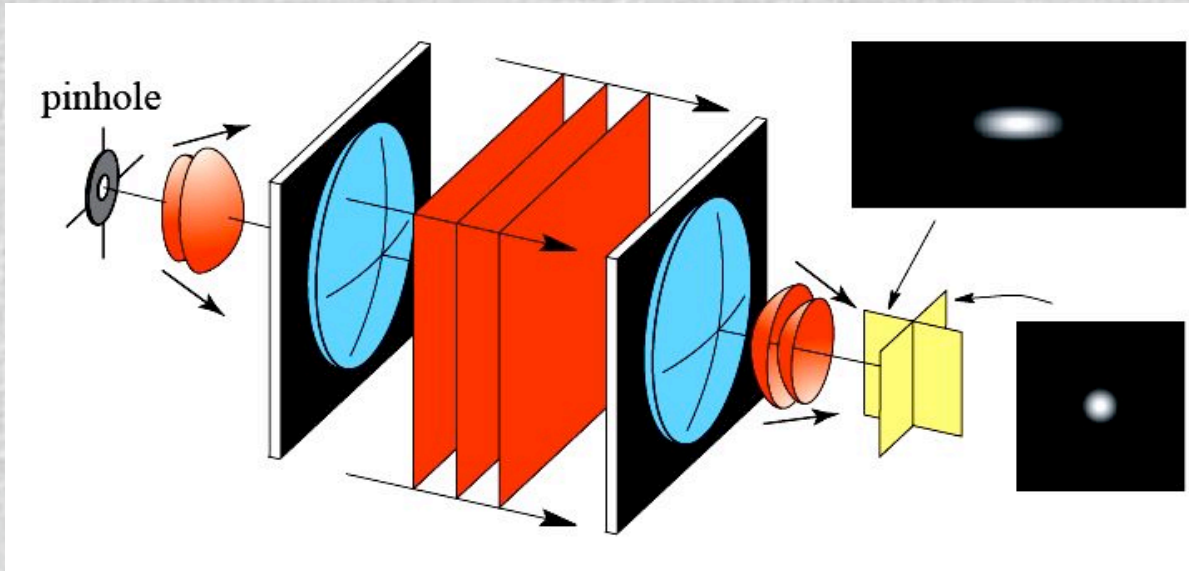
Through-focus  
image sections



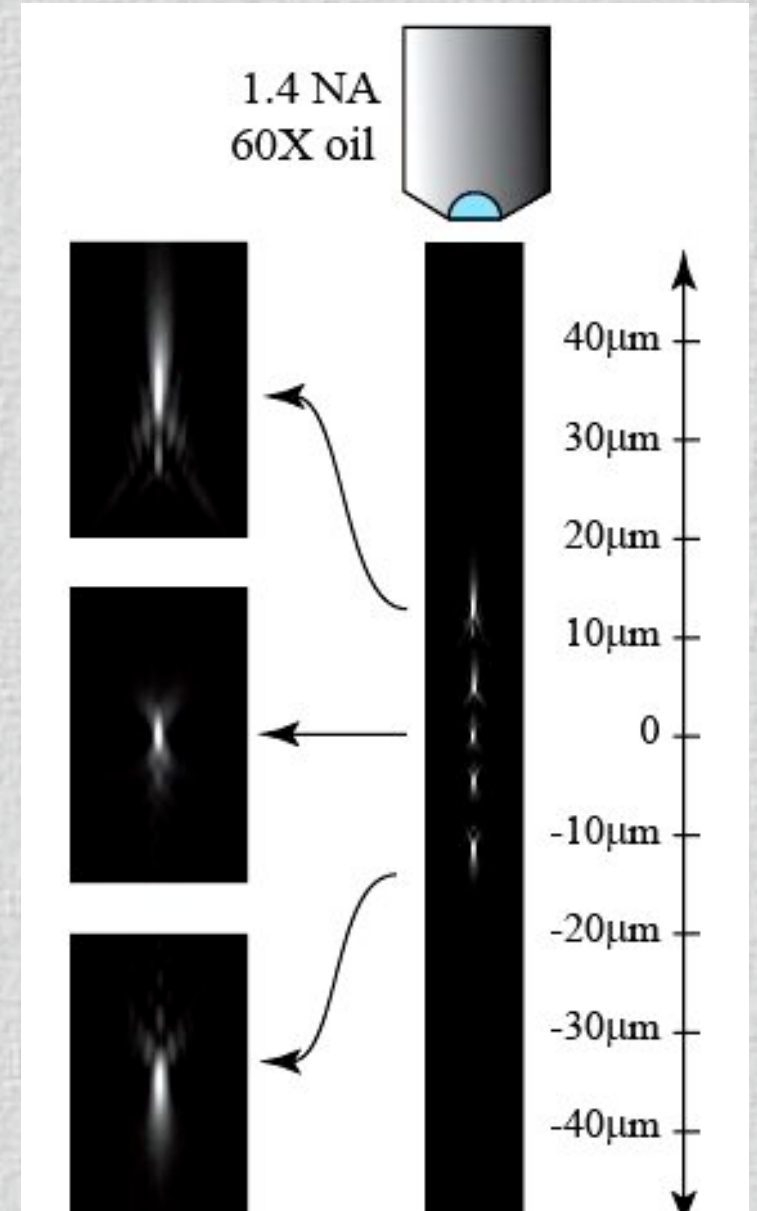
3D image data



# Scanning approaches

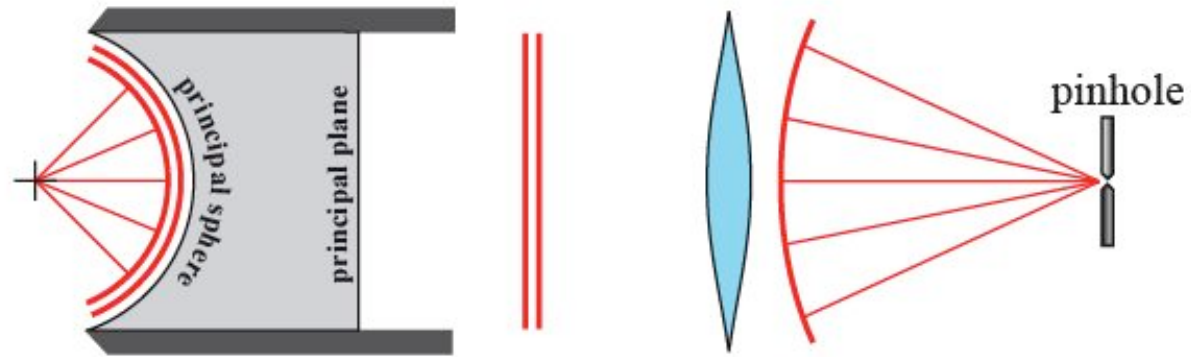


- **Scan sample xyz**
- **xy optically z sample**
  - Galvanometers – single point
  - Nipkow disc – many points
- **xy optically z optically**
  - AOM
  - Vari-focus lenses

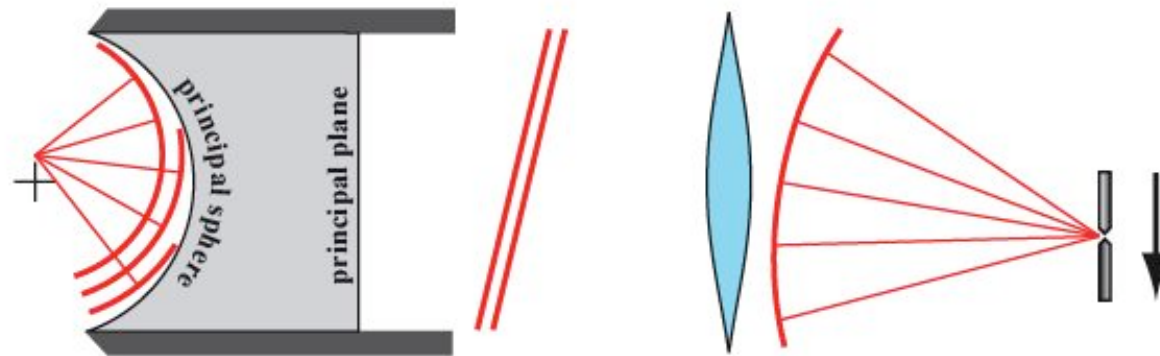


# The sine condition

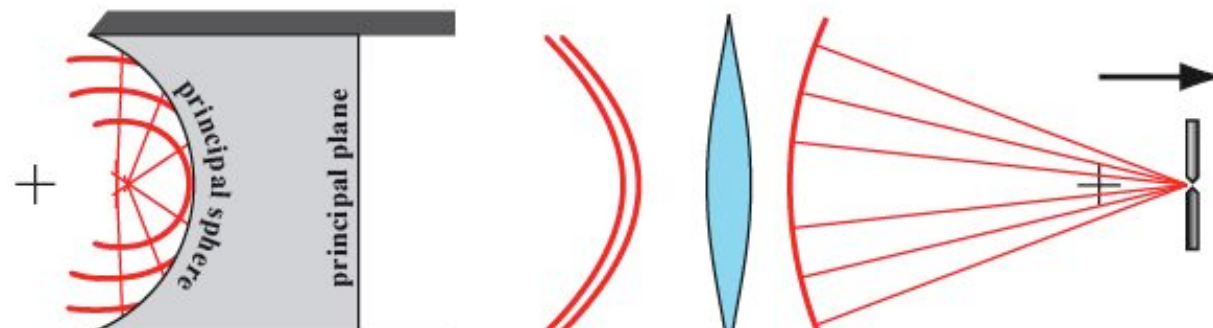
Focus



Lateral



Axial





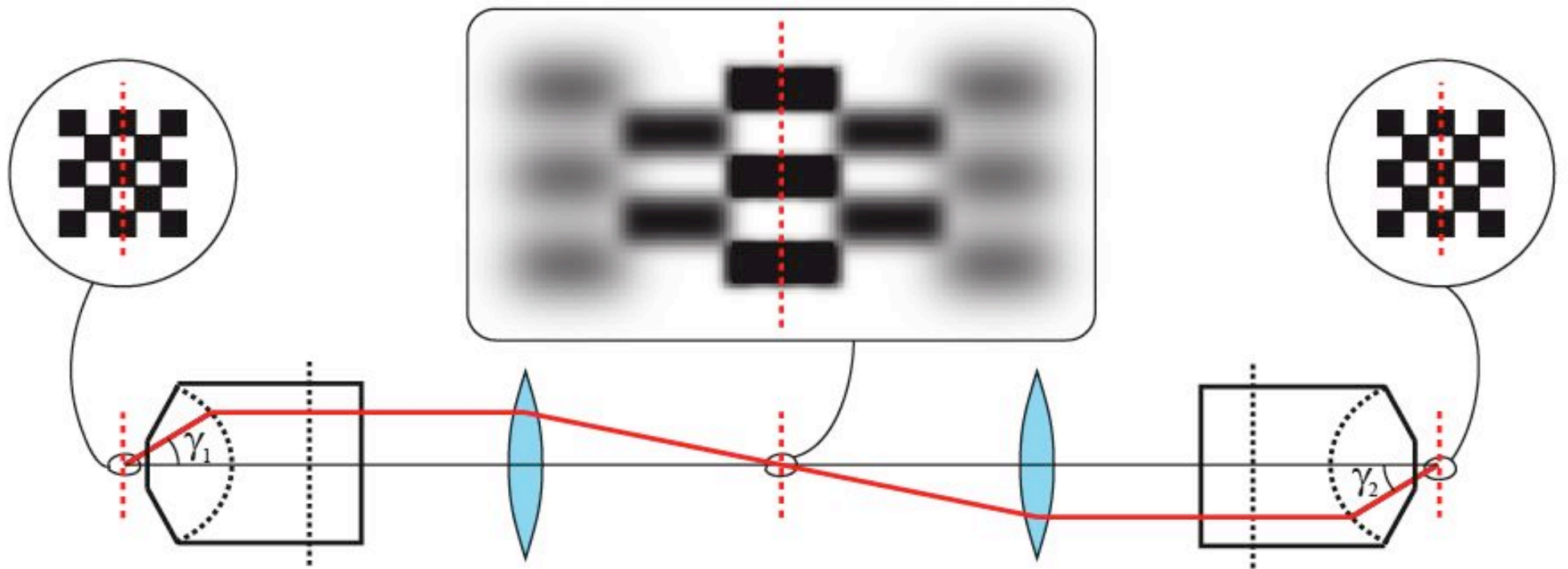
# Perfect imaging

$$u'(x', y', z') = C u\left(\frac{x'}{M}, \frac{y'}{M}, \frac{z'}{M}\right)$$

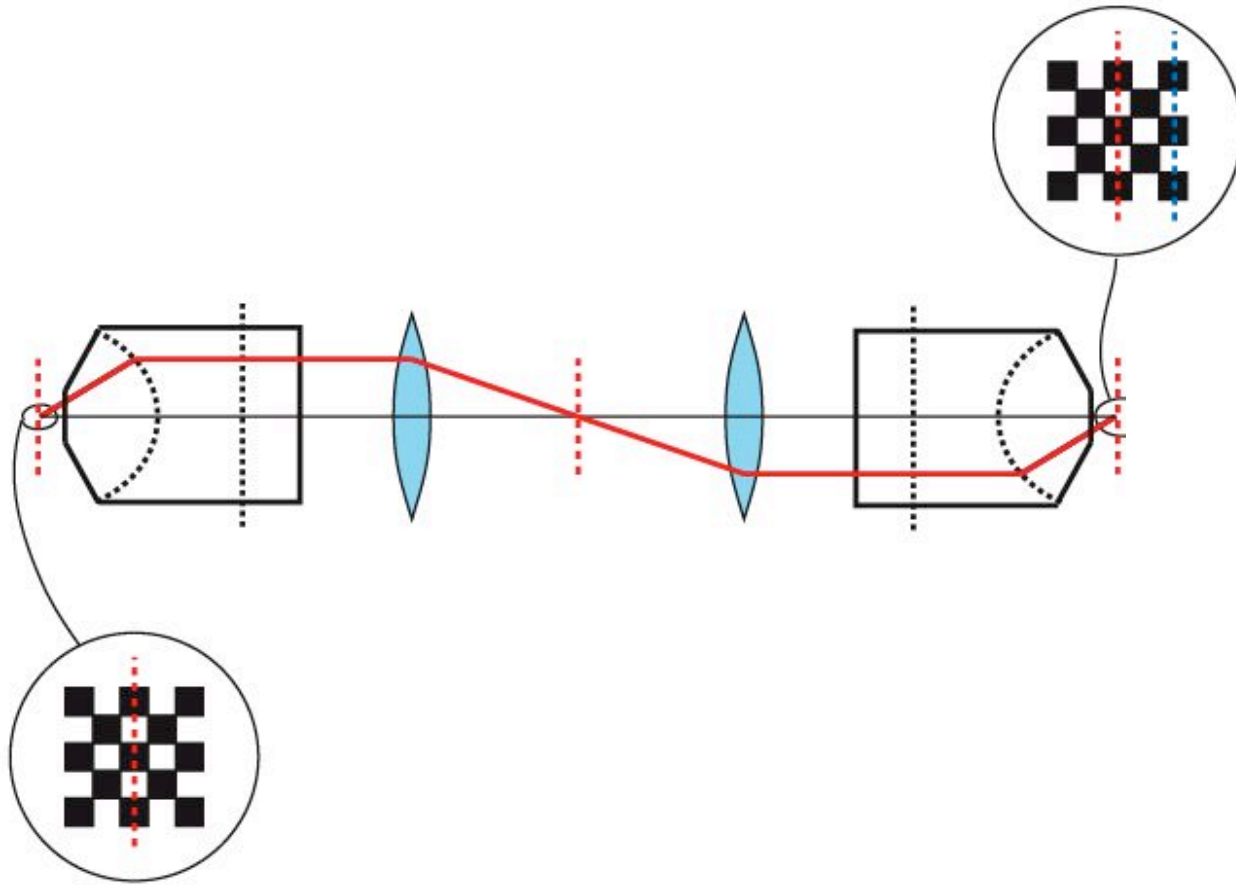
**Geometrical optics** -- sine, Herschel, Maxwell conditions

**Wave theory**

$$|M| = \frac{n_1}{n_2} \quad \gamma_1 = \gamma_2$$

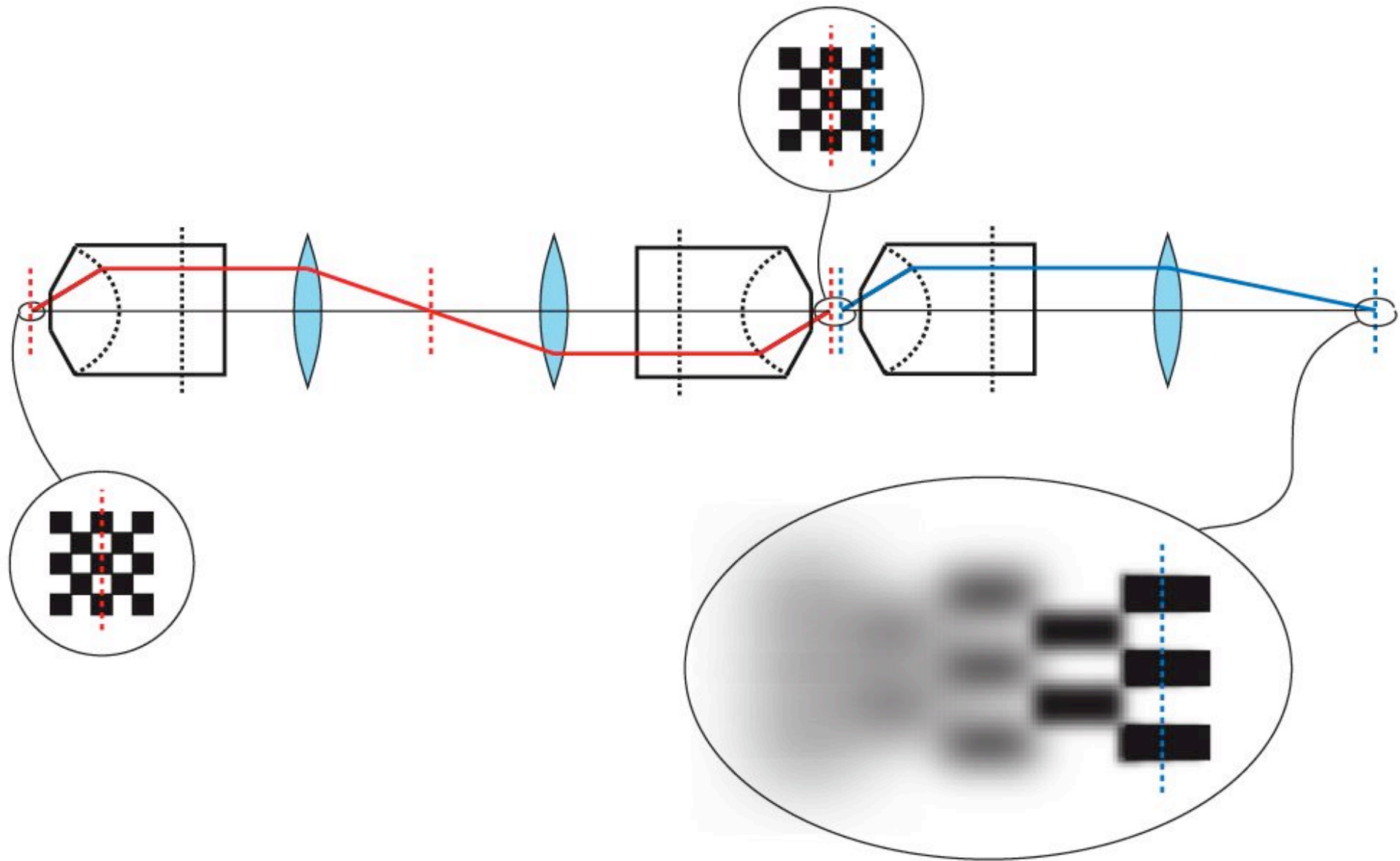


# Transmission system

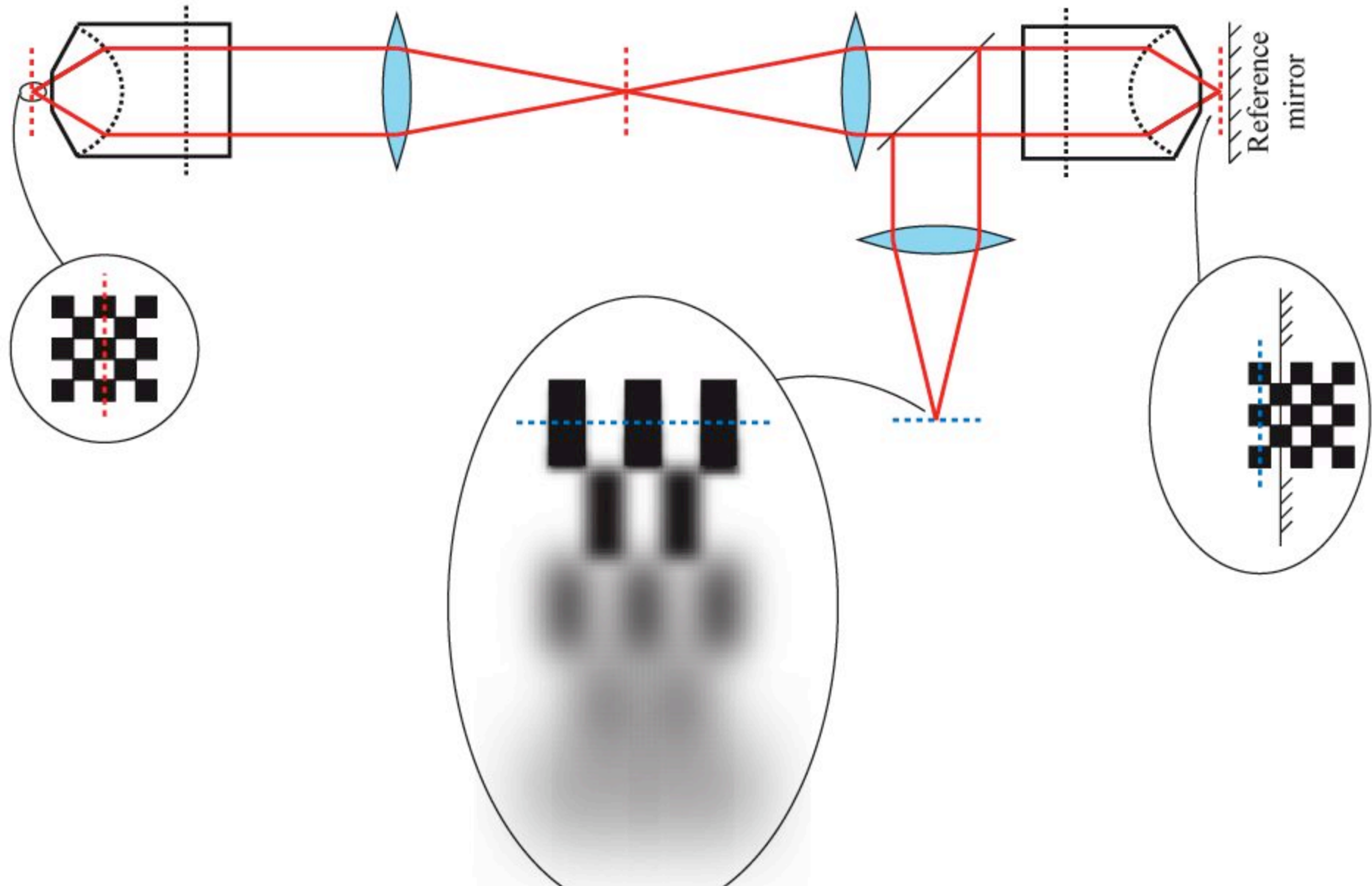




# Transmission system

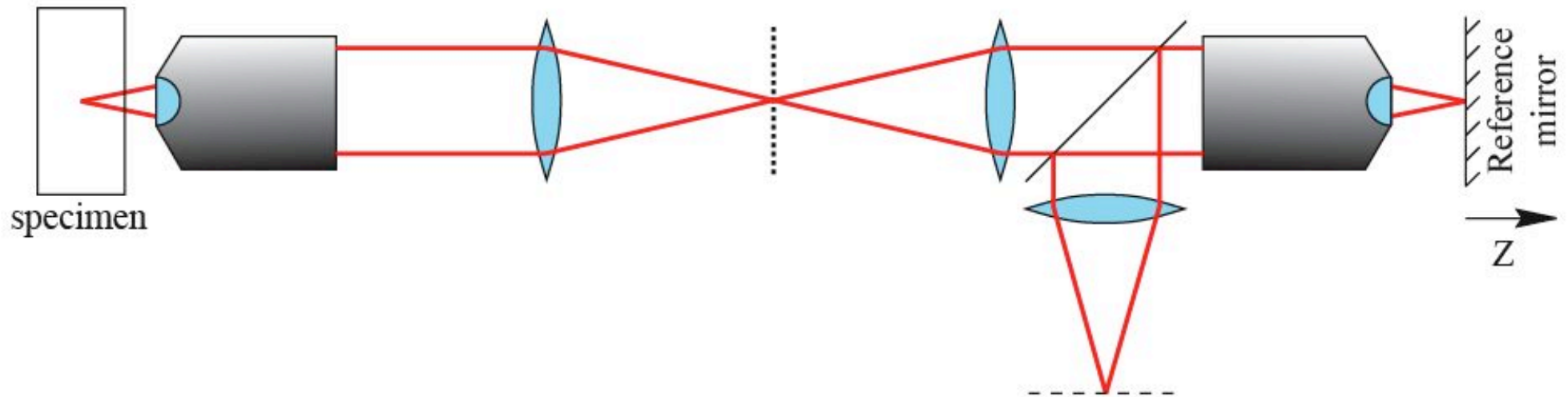


# Reflection system



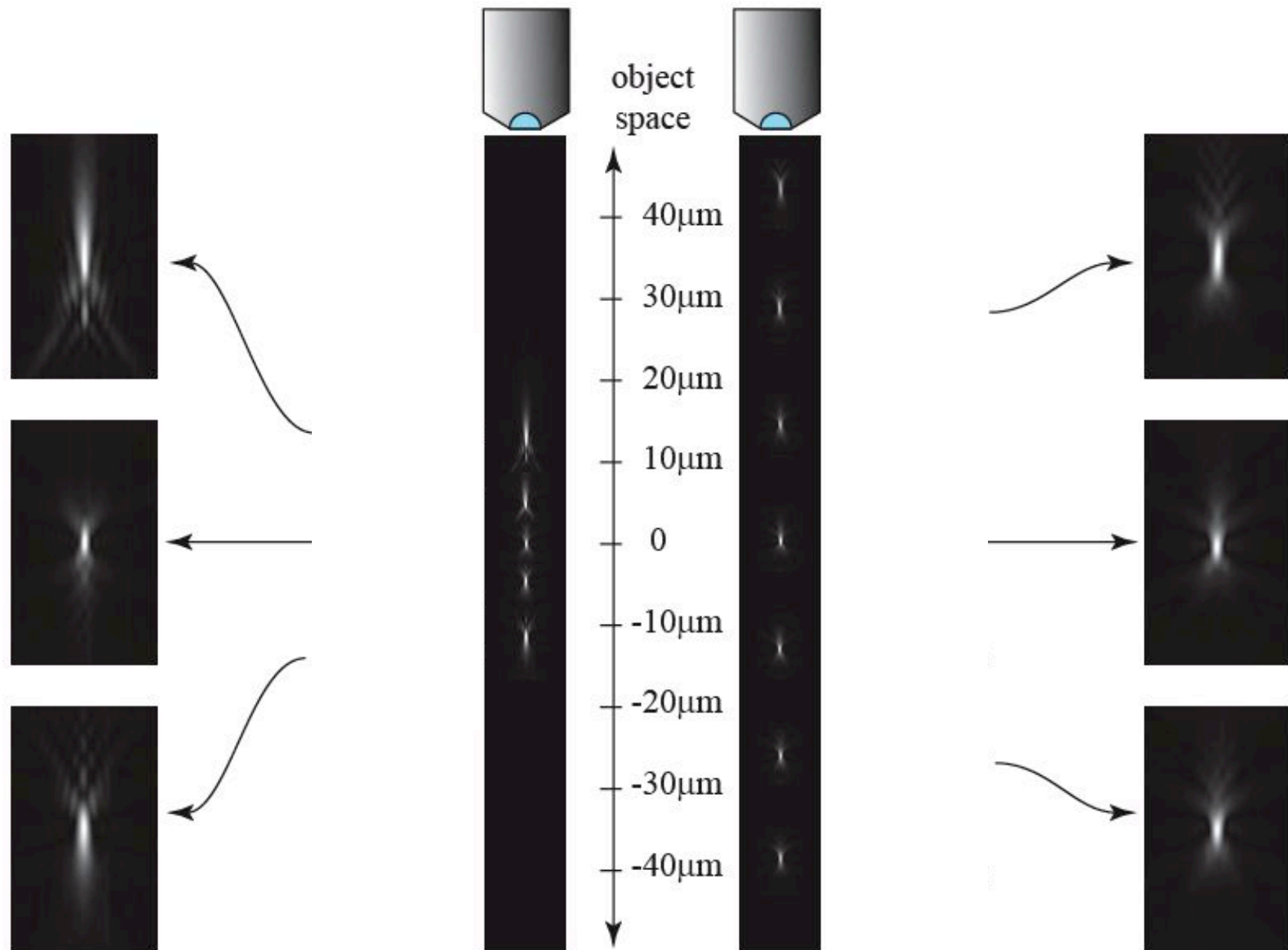


# Summary of approach



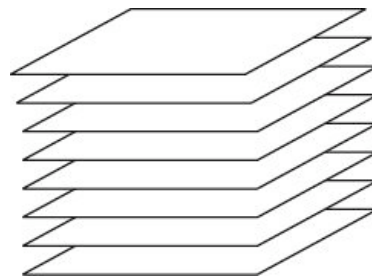
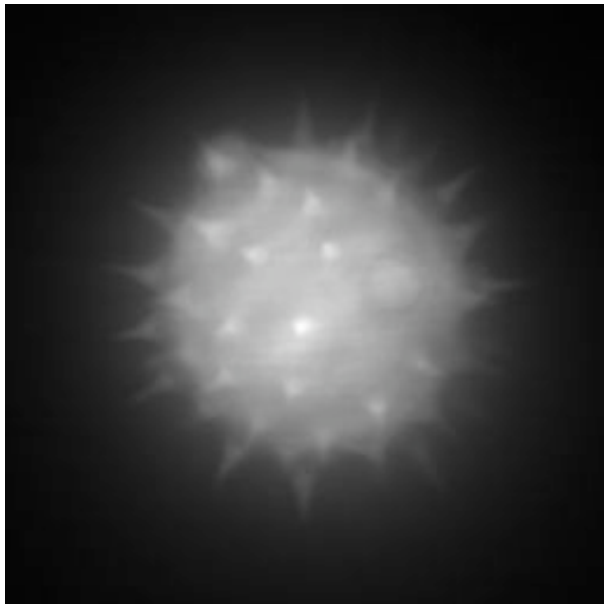
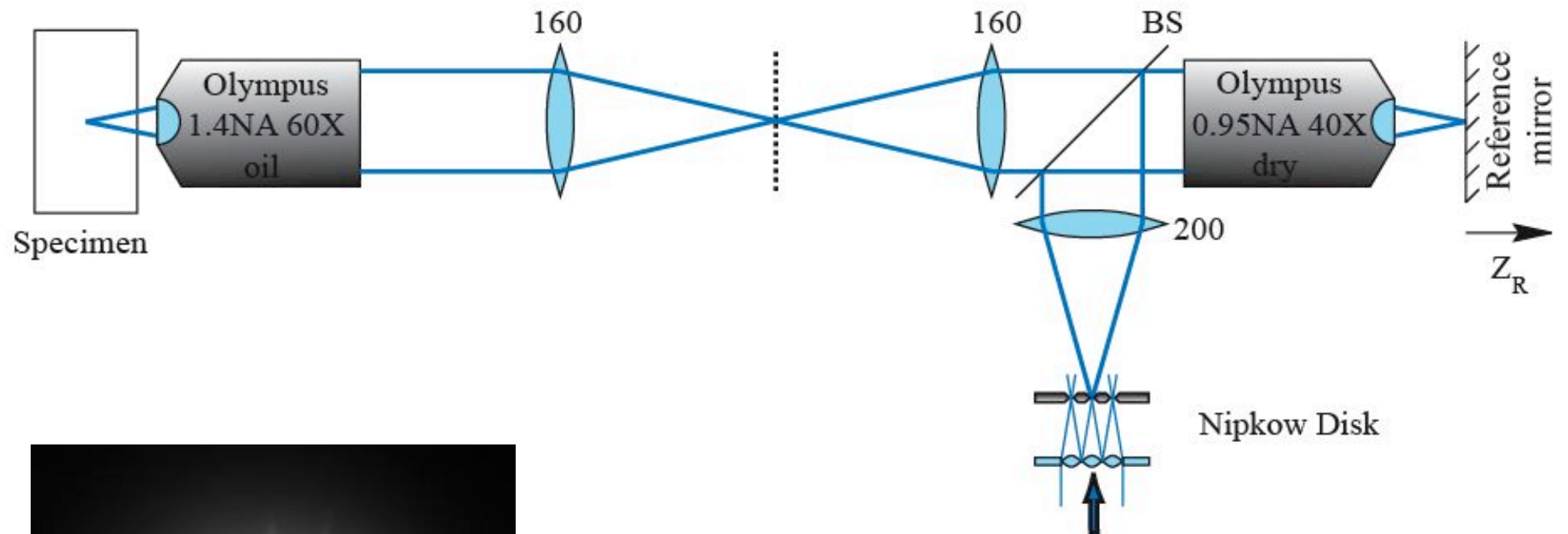
- 'relay' specimen to remote space
- Perfect image of object formed  
sine and Herschel conditions both fulfilled
- Fast focussing via mirror
- Specimen remains stationary during imaging

# New system





# Extended depth of field



Photometric Consultants Ltd.



# Summary

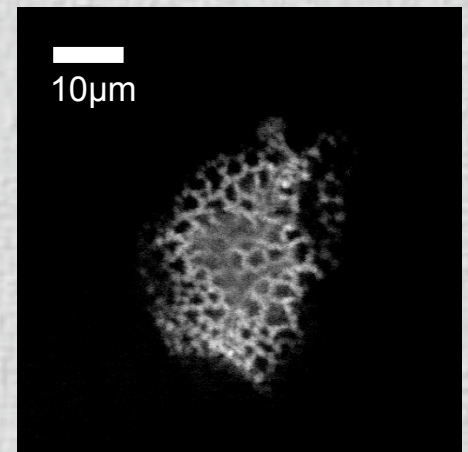
**Confocal microscope**

**Light efficient implementation**

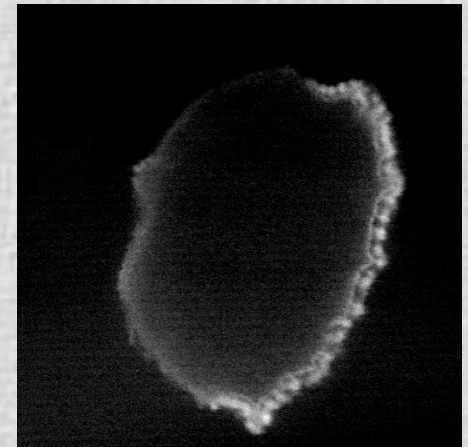
aperture correlation  
structured illumination

**Fast focussing**

live cell imaging



In focus



+ 20μm

